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	Filing Date		2005-05-13	
INFORMATION DISCLOSURE	First Named Inventor	Shunp	ou Li	
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/DNB II	/1	Kahp Y. Suh et al., "Capillary Force Lithography: Large-Area Patterning, Self-Organization, and Anisotropy Wetting," Adv. Funct. Mater., vol. 12, no. 6+7, pp. 405-413 (June 2002)					
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